

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Chopra et al.

Serial No.: 10/620,002

Filed: July 14, 2003

For: SLURRY FOR USE WITH FIXED-
ABRASIVE POLISHING PADS IN
POLISHING SEMICONDUCTOR DEVICE
CONDUCTIVE STRUCTURES THAT
INCLUDE COPPER AND A COPPER
BARRIER (as amended)

Confirmation No.: 7481

Examiner: L. Vinh

Group Art Unit: 1792

Attorney Docket No.: 2269-4373.2US

VIA ELECTRONIC FILING
July 11, 2008

AMENDMENT ACCOMPANYING REQUEST FOR CONTINUED EXAMINATION

Mail Stop RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Examiner:

This Amendment and the Request for Continued Examination (RCE) that it accompanies follow the Advisory Action of June 19, 2008, and the final Office Action of April 11, 2008, the shortened statutory period for response to which expires on July 11, 2008.

A listing of claims, in which revisions to the claims are presented, begins on page 2 of this paper; and

Remarks start at page 6 of this paper.